



PATENT  
Attorney Docket No. 81877.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al

Serial No: 09/670,917

Confirmation No: 1895

Filed: September 29, 2000

For: Semiconductor Device Manufacturing  
Method and Apparatus for Removing  
Silicon Nitride Formed in a Reaction  
Container

Art Unit: 2822

Examiner: Guerrero, Maria F.

I hereby certify that this correspondence  
is being deposited with the United States  
Postal Service with sufficient postage as  
first class mail in an envelope addressed  
to:

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on

April 25, 2005

Date of Deposit

Juanita Soberanis

Name

Signature Date 04/25/2005

Signature

Date

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the  
Commissioner for a three-month extension of time extending to April 25, 2005, the  
period for response to the Office Action dated October 25, 2004. Please charge the  
fee of \$1020 for this extension to Deposit Account No. 50-1314. The responsive  
paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account  
No. 50-1314. A copy of this petition is enclosed.

04/27/2005 EAREGAY1 00000015 501314 09670917

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Date: April 25, 2005

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

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